

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Mail Stop Patent Application
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Re: Inventors: Dan Maydan, Randhir P.S. Thakur, Kenneth S. Collins, Amir Al-Bayati, Hiroji Hanawa, Kartik Ramaswamy, Biagio Gallo, and Andrew Nguyen

Title: FABRICATION OF SILICON-ON-INSULATOR STRUCTURE USING PLASMA IMMERSION ION IMPLANTATION

Transmitted herewith is the **Continuation-In-Part** of prior application No. 10/646,533, filed on August 22, 2003.

Prior application information: Examiner: Unknown

Group Art Unit: 1763

Application elements:

☒ Specification, claims and abstract, totaling 166 pages

☒ Drawings totaling 95 pages, ☒ Formal

☒ Declaration and Power of Attorney

☒ Assignment of the invention to **Applied Materials, Inc.**

FEE CALCULATION

Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	59	-20=	39	X\$18.00	\$702.00
Independent Claims	2	-3=	0	X\$86.00	\$000.00
Basic Filing Fee				\$770.00	\$770.00
TOTAL FEES					\$1,772.00

☒ The Commissioner is hereby authorized to charge \$ 1,772.00 to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

☒ Please address all future correspondence to:

**PATENT COUNSEL
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I hereby certify that this correspondence is being deposited
 with the United States Postal Service as express mail in an
 envelope addressed to: Commissioner for Patents, P.O. Box
 1450, Alexandria, VA 22313-1450.
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 Date of Deposit Feb. 24, 2004

Signature _____

Emma Koh

Respectfully submitted,

Robert W. Mulcahy

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